

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

III re Patent Application of:)	Group Art Unit: 2823
Shunpei YAMAZAKI et al.)	Examiner: B. Kebede
Serial No. 09/894,125)	CERTIFICATE OF MAILING I hereby certify that this correspondence is being
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Honorable Commissioner of Patents		70

Honorable Commissioner of Patent P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Further in response to the Official Action dated May 21, 2003, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 10 of this paper.